

ELEC 207

Instrumentation and Control

7 – Displacement Transducers (1)

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Displacement measurement

Displacement, position and level

Displacement is defined as the movement of an object from one position to another. It can be:

- **Translational** (movement along a straight line);
- **Rotational** (angular movement).

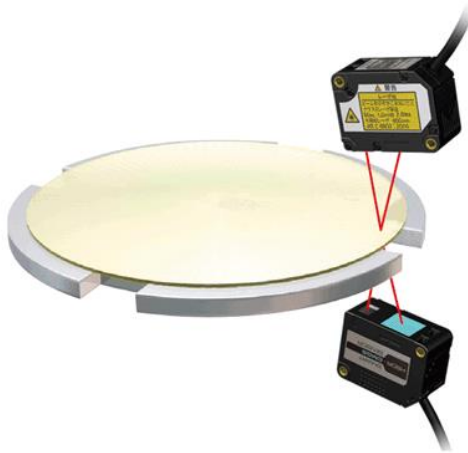
Displacement is measured by measuring a (new) position with respect to a reference (old) position:

- A displacement measurement is equivalent to a **position** or **level** measurement;
- It has a wide range of applications (robotics, process feedback control, performance evaluation, industrial automation, etc.).

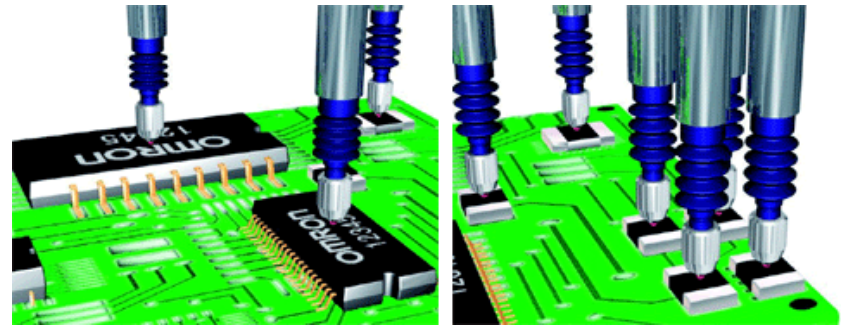
Displacement measurement

Application examples in industrial automation

- Semiconductor industry:



Wafer thickness measurement



Height measurement of electronic components

- Beverage industry:



Detection of fallen parts

Types of transducers (1)

Displacement and level transducers are based on different physical principles and technologies:

- **Resistive:**

- Typically based on potentiometers;
- A relatively simple and low-cost technology used in many applications.



- **Capacitive:**

- Used for high-resolution **non-contact** measurement of conductive targets;
- Used also to measure the thickness or density of non-conductive materials.



Displacement measurement

Types of transducers (2)

- **Inductive:**

- Reliable under harsh conditions, high signal quality and good temperature stability;
- Allow also non-contact measurements.



- **Optical:**

- Used for non-contact measurements;
- Typically employed to detect the position or rotational speed of a rotating shaft;
- Based on at least three essential components: a light source, a light detector and a light guidance device (e.g. lenses, mirrors, optical fibres, etc.).



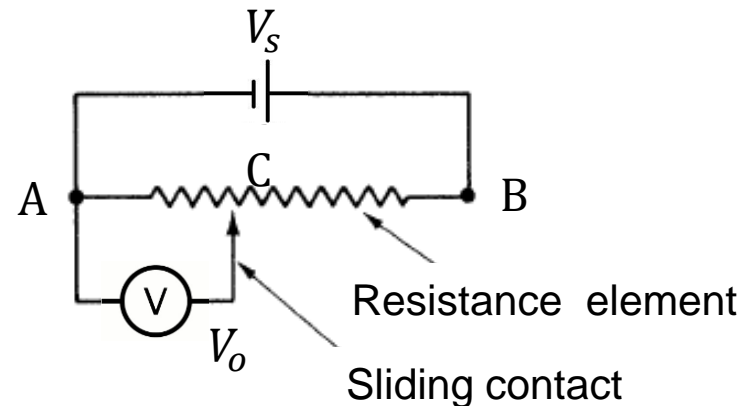
Resistive potentiometer

Principle of operation

A potentiometer consists of a resistor and a sliding contact:

- It acts as a resistive **voltage divider**:

$$V_o = V_s \frac{R_{AC}}{R_{AB}}$$



- The body whose motion is being measured is connected to the sliding contact:
 - There is a **linear relationship** between the distance AC (position of the body) and the output voltage:

$$V_o = V_s \frac{AC}{AB}$$

Resistive potentiometer

Drawbacks and limitations

This type of transducer is simple and low-cost, but not very accurate:

- If the resistance value is **high**, the resistance of the instrument measuring the output voltage (e.g., a voltmeter) can affect the output value (**loading effect**);
- If the resistance value is **low**, the output can be affected by the additional resistance of connecting wires (**parasitic resistance**);
- Moreover, in case of wire-wound potentiometers, the **resolution** is limited by the step increment (one turn of the wire):
 - Carbon-film or plastic-film potentiometers can be used to overcome this limitation.

Capacitive transducer

Principle of operation

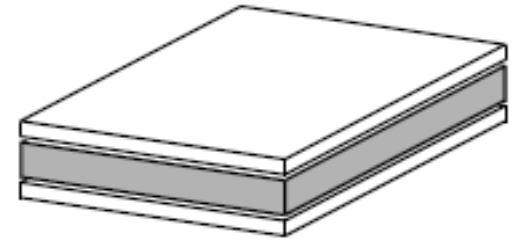
The capacitance of a capacitor with parallel conducting plates is:

$$C = \epsilon_0 \epsilon_r \frac{A}{d}$$

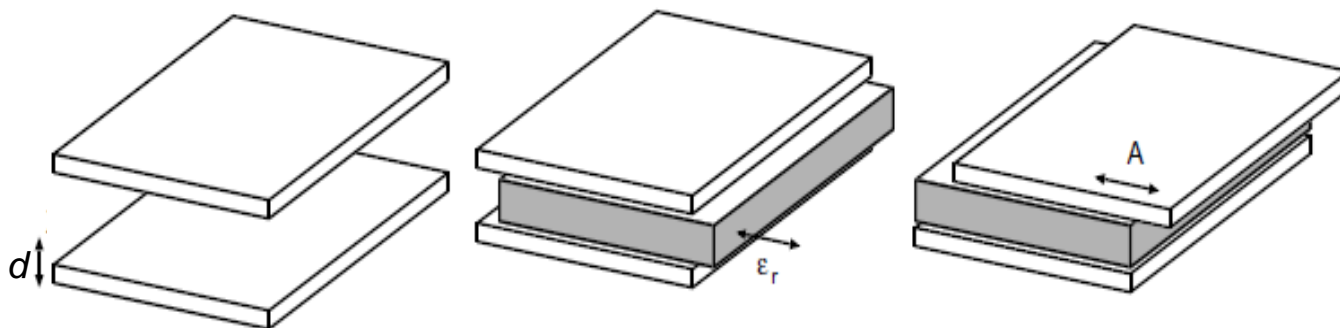
A: area of the plates

d: distance between them

ϵ_r : dielectric constant of the insulator



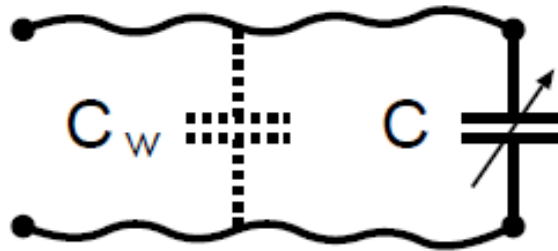
- Displacement can be sensed by varying any of the three variables: ϵ_r , A, d:
 - Only variations of ϵ_r and A produce a **linear response**.



Capacitive transducer

Drawbacks and limitations

The capacitance measurement is affected by the **wiring capacitance**, which is in parallel to the capacitor and therefore is added to the total measured capacitance:



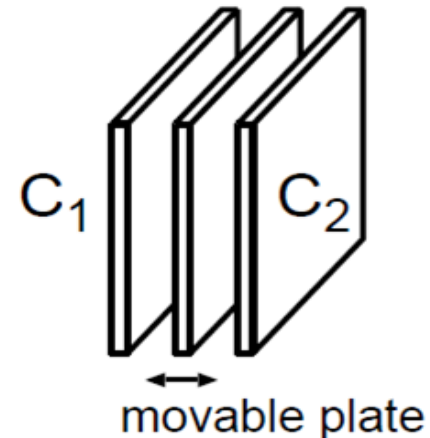
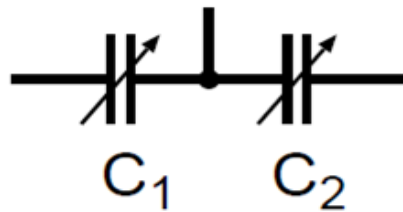
- A small change in the capacitance value can be affected by a large error;
- Using the **plate separation** d to measure the displacement would result in a higher sensitivity (and better accuracy), but the response would be **non-linear**.

Differential capacitance transducer

Change in plate separation

The transducer response can be **made linear** by using a **differential capacitance transducer**:

- One movable plate is placed between two fixed plates, thus producing two variable capacitors:



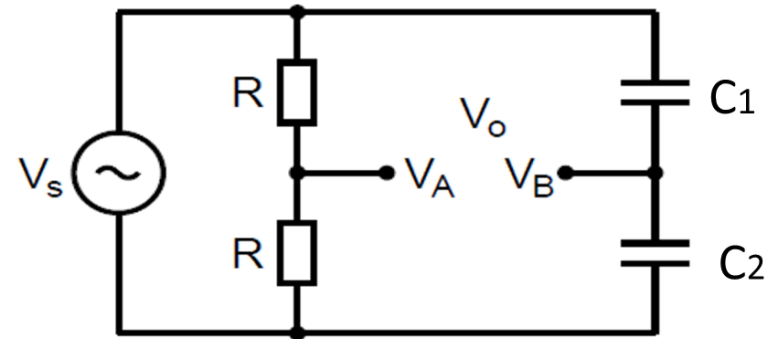
- The capacitance change corresponding to a displacement can be measured by a **capacitance bridge**.

Differential capacitance transducer

Capacitance bridge (1)

The change in capacitance can be measured by an **AC bridge**:

$$V_o = V_B - V_A = V_s \frac{\frac{1}{j\omega C_2}}{\frac{1}{j\omega C_1} + \frac{1}{j\omega C_2}} - \frac{V_s}{2} =$$
$$= V_s \left(\frac{C_1}{C_1 + C_2} - \frac{1}{2} \right)$$



- When the movable electrode is in the central position, the bridge is **balanced**:

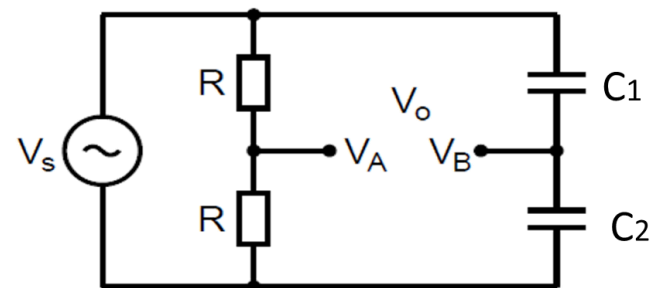
$$C_1 = C_2 \quad \longrightarrow \quad V_o = 0$$

Differential capacitance transducer

Capacitance bridge (2)

- When the movable electrode is shifted by Δx (e.g. to the right), an unbalance appears:

$$C_1 = \varepsilon_0 \varepsilon_r \frac{A}{d + \Delta x} \quad , \quad C_2 = \varepsilon_0 \varepsilon_r \frac{A}{d - \Delta x}$$



- In this case the **output voltage** of the bridge is:

$$\begin{aligned} V_o &= V_s \left(\frac{C_1}{C_1 + C_2} - \frac{1}{2} \right) = V_s \left(\frac{\frac{1}{\frac{d + \Delta x}{\varepsilon_0 \varepsilon_r A}}}{\frac{1}{\frac{d + \Delta x}{\varepsilon_0 \varepsilon_r A}} + \frac{1}{\frac{d - \Delta x}{\varepsilon_0 \varepsilon_r A}}} - \frac{1}{2} \right) = \\ &= V_s \left(\frac{1}{\frac{d - \Delta x + d + \Delta x}{d - \Delta x}} - \frac{1}{2} \right) = V_s \left(\frac{d - \Delta x}{2d} - \frac{1}{2} \right) = -V_s \frac{\Delta x}{2d} \end{aligned}$$

Differential capacitance transducer

Transfer function

The transfer function of this transducer is therefore:

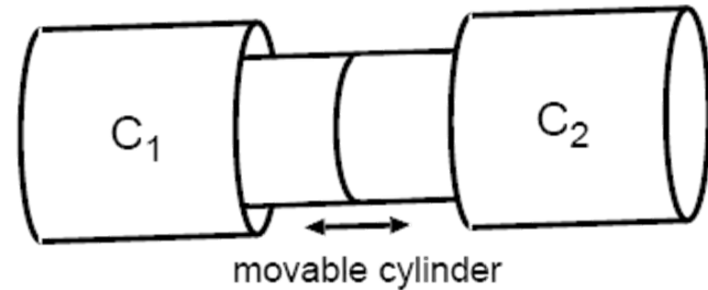
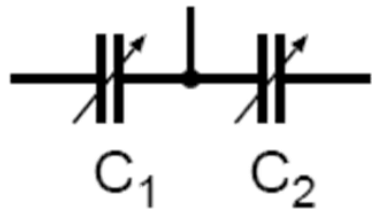
$$V_o = -V_s \frac{\Delta x}{2d}$$

- The bridge is an AC circuit, so V_s and V_o are **phasors**:
 - The **magnitude** of V_o is proportional to the magnitude of the displacement;
 - The **phase** of V_o provides the direction of the displacement.
- Therefore both amplitude and phase must be measured.

Differential capacitance transducer

Change in overlapping area

An alternative solution is to change the **overlapping area** of plates in a differential capacitance transducer:



- The movement of the movable cylinder produces an opposite change in the overlapping electrode areas in the two capacitors:

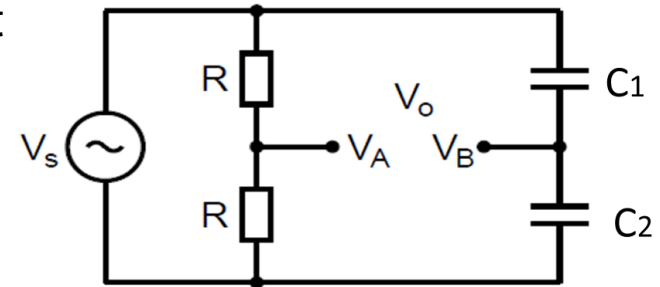
$$C_1 = \epsilon_0 \epsilon_r \frac{A - \Delta A}{d} \quad , \quad C_2 = \epsilon_0 \epsilon_r \frac{A + \Delta A}{d}$$

Differential capacitance transducer

Capacitance bridge

A capacitance bridge can be used again to convert this change in capacitance into a voltage:

- The **output voltage** of the bridge is now:



$$V_o = V_s \left(\frac{C_1}{C_1 + C_2} - \frac{1}{2} \right) = V_s \left(\frac{A - \Delta A}{A - \Delta A + A + \Delta A} - \frac{1}{2} \right) =$$
$$= V_s \left(\frac{A - \Delta A}{2A} - \frac{1}{2} \right) = -V_s \frac{\Delta A}{2A}$$

- Since $\Delta A = L\Delta x$ (being L the circumference of the cylinder), the output voltage is proportional to the displacement Δx as well.

References

Textbook: Principles of Measurement Systems, 4th ed.

For further explanation about the points covered in this lecture, please refer to the following chapters and sections in the **Bentley** textbook:

- Chapter 8, Sec. 8.1.1: **Potentiometers for linear and angular displacement measurement;**
- Chapter 8, Sec. 8.2: **Capacitive sensing elements;**
- Chapter 9, Sec. 9.1.3: **Design of reactive deflection bridges.**

NOTE: Topics not covered in the lecture are not required for the exam.

References

Textbook: Measurement and Instrumentation, 2nd ed.

For further explanation about the points covered in this lecture, please refer to the following chapters and sections in the **Morris-Langari** textbook:

- Chapter 19, Sec. 19.2.1: **Resistive potentiometer**;
- Chapter 19, Sec. 19.2.3: **Variable capacitance transducers**;
- Chapter 7, Sec. 7.2.4: **AC bridges**.

NOTE: Topics not covered in the lecture are not required for the exam.